

European XFEL in-kind contributions: a look into the main features of the designed vacuum systems

Antonio Bonucci– IKC Supply Chain Manager European XFEL Albert-Einstein-Ring 19 22761 Hamburg Germany European

Overview



- Short overview of the European XFEL project
- Vacuum Technology in IKC in the construction phase
- UHV Guidelines for X-Ray Beam Transport Systems
- Conclusions

European

Main facts about the project





The European XFEL Facility in Hamburg is an applied research facility

- Generation of X-ray flashes: 27 000/s
- Superconducting linear accelerator for electrons (energy level 17.5 GeV)
- 3.4 km long machine in 5.8 km underground tunnels
- 3 sites above ground and 5 experimental stations (3 in the start-up)
- Construction :
- Cost 1.15 B€ (2005) or 1.43 B€ (2013)
- 12 countries participate in the construction through 21 institutes
- 48 Work Packages
- 76 in-kind contributions
- Lifetime 20 years 2016-2036

20 May 2015 – AIV XXII Conference Antonio Bonucci – In-kind contribution Supply Chain manager



XFEL What can the European XFEL do?





X-ray light See samples at atomic resolution

Ultrashort flashes Film (bio-)chemical reactions

Intense X-ray pulses Study single molecules or tiny crystals



XFEL Opportunities: biology, medicine, pharmacology

- Molecular movies reveal biochemical processes
 - Causes of protein misfolding → treatments for Alzheimer's, BSE, etc.
 - Understanding enzymatic action in greater detail

 → better medicines, fewer side effects
 - Viewing mechanisms of infection
- High intensity X-rays show structures in greater detail
 - Searching for weaknesses in viral and bacterial outer coats





XFEL Opportunities: chemistry and materials science

- Atomic-level imaging can uncover action of catalysts
 - Better catalytic converters lessen impact of emissions
 - Less toxic production processes
- Studying structure and properties of materials as never before
 - How properties (e.g. durability, conductivity, magnetism) manifest
 - Reducing atoms needed to store digital information → ultrahigh-capacity hard drives





20 May 2015 – AIV XXII Conference Antonio Bonucci – In-kind contribution Supply Chain manager



XFEL Injector: creating bunches of electrons



- Optical laser strikes Cs₂Te surface, releasing a cloud of electrons
- Electrons move into a magnetic field, shaping into a bunch
- Small accelerator module "fires" bunch into the main electron accelerator



XFEL Accelerator: electrons at close to light speed



100 accelerator modules over 2 km bring the electron bunch to near light speed and high energies

Superconducting niobium cavities powered by intense radio frequency accelerate electrons

European In-Kind contributions SASE undulators: inducing electrons to emit X-ray light





Alternating magnetic fields cause electrons to take "slalom" course

- Electrons release X-rays with each turn
- SASE process builds intense, laser-like flashes





European



Hard X-rays

SPB: Single Particles, Clusters, and **Biomolecules**

Will determine the structure of single particles, such as atomic clusters, viruses, and biomolecules

MID: Materials Imaging and Dynamics

Will be able to image and analyze nano-sized devices and materials used in engineering

FXE: Femtosecond X-Ray Experiments

Will investigate chemical reactions at the atomic scale in short time scales-molecular movies

HED: High Energy Density Physics

Will look into some of the most extreme states of matter in the universe, such as the conditions at the center of planets



SQS: Small Quantum Systems

Will examine the quantum mechanical properties of atoms and molecules.

SCS: Spectroscopy and Coherent Scattering

Will determine the structure and properties of large, complex molecules and nano-sized structures.



20 May 2015 – AIV XXII Conference Antonio Bonucci – In-kind contribution Supply Chain manager



Underground Injector building







Oct. 2009

Underground injector building: 7 levels, 38m deep



RF power components



Electron gun



Main shaft



Main tunnel is 2 km long





Utilities installed in accelerator tunnel



Floor laying



Vehicle for cryomodule transport



12 countries contribute to the European XFEL Facility





Each country contributes either in cash, in-kind, or both to the construction phase





Overview of in-kind contributions end 2014

Efforts by IKC Office



- 9 Countries
- 21 Institutes
- 78 IKCs
- 610 Milestones
- 560 M€ (2005)

Status end 2014

- 67 IKCs allocated
- 216 Milestones completed
- 10 IKCs completed
- Project delay, but already many components delivered

Prepare agreements

- Implement changes
- Validate milestones
- Follow-up and control
- Verify achievements





Main components delivered

- Super-conducting cavities: 540/800
- Cryostats: 85/100
- Warm magnets: 715/715
- Cold magnets: 100/100



European XFEL

Vacuum Technology in IKC



Vacuum Technology is a fundamental brick all over the facility.

The beam vacuum system of this facility contains sections operated at room temperature as well as at 2 K in the areas of the superconducting accelerating structures. Accordingly, the requirements, technical challenges and solutions for the various sections are quite different.

The Vacuum Technology in the In-Kind contribution are treated in the following work packages:

- WP08/ RU18 "Cold Vacuum", collaboration with DESY (Deutsches Elektronen-Synchrotron) and BINP (Budker Institute of Nuclear Physics) Novosibirsk

Superconducting Linear Accelerator

WP19/RU19 "Warm Vacuum", collaboration with DESY and BINP Novosibirsk

Injector and Bunch Compressors, Collimation and Beam distribution, Undulators, Transport Beam Lines and Beam Dumps

Scientific Instruments with different requirements

DESY Technical Specification and guidelines for UHV Components are available at the address http://edmsdirect.desy.de/edmsdirect/item.jsp?edmsid=D00000001425601,D,1,2



WP08/RU18: deliverables



Tasks DE08 (DESY):

Accelerator modules

- Cleaning of 808 inter-cavity bellows
- Cleaning of 101 coupler pump lines with 808 coupler bellows

Purchase and cleaning of 202 manual gate valves

Purchase, cleaning and commissioning of 101 titanium sublimation pumps and 101 sputter ion pumps

Coupler vacuum

Cryogenic boxes

Design, manufacture and cleaning of the vacuum piping for the cryogenic boxes

Purchase and cleaning manual gate valves



20 May 2015 – AIV XXII Conference Antonio Bonucci – In-kind contribution Supply Chain manager

- Tasks RU18 (BINP):
- Production of 848 cavity bellows
- Production of 848 coupler bellows
- Production of 106 pump lines
- Shipment to Saclay for integration (FR02 and FR03)



Cavity bellows prototypes are validated

Specification:

Cu coating 15 ± 5 µm

- Heat treatment for quality check of Cu coating at 300° C
- He leak rate < 10⁻¹⁰ mbar l/s
- vacuum firing according to CERN procedure in clean furnace with p < 10-5 mbar l/s at 950 $^\circ\,$ C

The bellows need to be particle free. The particle cleaning will be done at DESY. Any change in the design and manufacturing of the vacuum components have to be done in a way to allow particle cleaning with wet processes (US bath, rinsing with ultra pure water) and drying with warm gas ($\leq 100^{\circ}$ C) before installation.

WP19/RU19: deliverables



Tasks DE19 (DESY):

European

- Gun + vacuum system before first module
- Injector except BC0 chicane (RU19) and laser heater (SE03)
- Injector dump vacuum
- BC1 and BC2 except chicane (RU19) ca. 150 m, average pump distance.
 3-5 m
- BC1 and BC2 dump vacuum
- Temporary beamline
- Collimation except main collimators (RU19), ca. 215 m , a.p.d ca. 6 m
- Undulator vacuum chambers (SASE1, SASE2, SASE3) (92 chamber)
- Beam Distribution
- Main dumps

WP19 does not supply diagnostic and special diagnostic components (WP17 and WP18) but WP19 has to take care of quality for all WP19 and non-WP19 vacuum components

Purchase, cleaning and commissioning of sputter ion pumps

Tasks RU19 (BINP):

Production of:

- Chicane sections BC1, BC2: 2 units
- Chicane section BC0: 1 unit
- Collimators: 5 units
- Intersections of Undulators beam lines: 100 units
- Vacuum system for beam distribution: 1620 meters
- Temporary beam lines tubes: 200 m
- Delivery to DESY for integration (DE19)



Compensator



BC dipole chamber

Vacuum system for beam distribution: For pressure simulations an outgassing rate of Q = 5.10⁻¹¹ mbar l/s/cm2 should be assumed. The aim is an average pressure of p = 2.10⁻⁸ mbar.



FXE experiment (Prof. Christian Bressler) DK01 In UHV components

P<1e-7 about 1e-8/1e-9

SQS experimnt (Dr. Michael Mayer) SE10/SE11

P~1e-10 mbar



UHV Guidelines for X-Ray Beam Transport Systems



The guidelines are available on <u>http://www.xfel.eu/project/organization/work_packages/wp_73</u> With detailed information about:

UHV-compatible design (Flanges , Designs) ... for instance use flanges knife-edge" type (according to ISO 3669-2:2007) that are sealed by means of a flat circular gasket made of oxygen-free high conductivity (OFHC) copper. The gasket cannot be reused.

UHV-compatible materials

Туре	Compatible	Incompatible
Pure metal	Aluminium Beryllium Copper Indium Molybdenum Tantalum Titanium Tungsten	(e.g. Cadmium, Lead, Zinc)
Stainless steel	Preferred types: 304L and 316L for pipes, 316LN ESR for flanges	Steel containing incompatible materials (e.g. 303, 303S, 303Se)
Alloy	Appropriate aluminum alloys Beryllium-copper DENSIMET [®] GLIDKOP [®] INCONEL [®] 600, 718 Tin-bronze	Inappropriate aluminium alloys (e.g. alloys containing lead) Zinc (e.g. brass)
Other	Aluminium ceramics Boron carbide (B ₄ C) Diamond, Sapphire Macor [®] , PEEK, PI (Kapton [®] , Vespel [®])	Organic materials (with a few exceptions) Glue



UHV Guidelines for X-Ray Beam Transport Systems



- Electrical connections inside vacuum (Kapton®- or ceramic-insulated)
- Feedthroughs:

Electrical (Feedthroughs used for electrical connections into the vacuum system must be of the ceramic-to-metal type. No glass-to-metal feedthroughs are permitted.)

Mechanical (Bellow-type mechanical feedthroughs or magnetically coupled feedthroughs have to be used to impart a rotational or linear movement to the vacuum. O-ring-sealed feedthroughs are not permitted.)

Guidelines for UHV systems (Manufacturing and assembly ,Cleaning of large items and small parts, handling, Packing)

For instance for large parts:

- Chemical mechanical precleaning (based on HNO3)
- > Rinsing with water (resistivity \geq 1 M Ω cm-1 at 25° C)
- Depending on the dimensions of the item to be cleaned, do one of the following:
 - Long pipe sections: Anodical cleaning (based on H2SO4 and H3PO4)
 - > Vacuum chambers, vessels or buffers: Pickling (based on HF and HNO3)
- > Rinsing with water (resistivity \geq 1 M Ω cm-1 at 25° C)
- Chemical passivation of the surface (based on HNO3)
- > Rinsing with water (resistivity ≥1 MΩcm-1 at 25° C)
- > Final treatment (for particle-free cleaning, continue with Section 4.1, "Cleaning and assembly")
 - > Rinsing with 80° C DI water (resistivity ≥ 15 MΩcm-1 at 25° C)
 - Drying with Nitrogen (quality 5.0 or better)



UHV Guidelines for X-Ray Beam Transport Systems



Particle-free UHV systems

You must verify the absence of particles in the cleaned components inside a cleanroom with ISO Class 5 or better. Therefore, clean the components with particle-free ionized nitrogen. After 5 minutes of using a gas throughput of 28 l/min, a maximum of 10 particles per minute with a size \geq 0.3 µm should be detected.

Vacuum tests:

- Leak tests:
 - Integral leak rate acceptance criterion Make sure that the integral leak rate (sum of all leaks) is ≤ 1.10¹⁰ mbar·l·sec⁻¹.

Residual gas analysis

- Acceptance criteria for unbaked vacuum systems
 - The mass 18 peak of the leak-free system reaches a pressure below 5.10-8 mbar.
 - After 15 hours of pumping the RGA spectra are recorded:
 - All mass peaks between mass 18 and 44 have to be 100 times lower than the mass 18 peak, except masses 28, 32, and 44.
 - All mass peaks from mass 45 have to be 1000 times lower than the mass 18 peak.
- Acceptance criteria for baked vacuum systems
 - Leak-free system reaches a total pressure below 10⁻⁷ mbar.
 - Sum of the partial pressures of masses from mass 45 on to at least mass 100 is less than 10⁻³ of the total pressure.
 - For documentation, a mass spectrum (at least masses 1–100 amu, resolution 1·10-14 mbar)) of each component is needed, as well as a reference spectrum of the applied pumping system itself.
 - The integral specific desorption rate for baked components should be $\leq 5-10^{-12}$ mbar·l·sec⁻¹·cm⁻².

European

Conclusions

27

- Vacuum technology is one of the most important component of XFEL project
- In Kind Contribution has been allocated both for the warm and for the cold vacuum
- UHV and Particle-free requirements have been extensively defined with detailed differences in the different areas of the facilities.

Acknowledgements:

 Budker Institute of Nuclear Physics, Novosibirsk,
 Dr. Alexander Krasnov,

 Prof. Vadim Anashin
 Prof. Vadim Anashin

 Deutsches Elektronen-Synchrotron, Hamburg,
 Dr. Lutz Lilje

 Dr. Sven Lederer
 Dr. Sven Lederer

Dr. Martin Dommach and all the staff of European XFEL